

10020764
12/12/01



PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10020764	FILING DATE 12/12/2001	CLASS 438 257	SUBCLASS 444	GAU 2811	EXAMINER Vikki Trinh
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**CONTINUING DATA VERIFIED:

NO

** FOREIGN APPLICATIONS VERIFIED:

NO

PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		ATTORNEY DOCKET NO 01-807
35 USC 119 conditions met <input type="checkbox"/> yes <input checked="" type="checkbox"/> no		
Verified and Acknowledged Examiners's initials		
TITLE : Substrate laser marking		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-435L(Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for O.G.
Assistant Examiner		DRAWING	
		Sheets Drawg.	Figs. Drawg.
Primary Examiner		Print Fig.	
Application Examiner			
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